



PATENT
Attorney Docket No. 04329.2409-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Kei YOSHIKAWA et al.) Group Art Unit: 2624
Application No.: 09/662,219) Examiner: Samir Anwar AHMED
Filed: September 14, 2000) Confirmation No.: 9438
For: PATTERN CORRECTING METHOD OF)
MASK FOR MANUFACTURING A)
SEMICONDUCTOR DEVICE AND)
RECORDING MEDIUM HAVING)
RECORDED ITS PATTERN)
CORRECTING METHOD)

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed April 6, 2007, the period for response having been extended to September 6, 2007, by a request for extension of two months and fee payment filed concurrently herewith, please amend the above-identified application as follows:

Amendments to the Specification are included in this paper.

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment sections of this paper.